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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Kouichi MEGURO et al.

Group Art Unit: 2822

Serial No.: 10/718,677

Examiner: Kiesha L Rose

Filed: November 24, 2003

Confirmation Number: 1220

SUBSTRATE SHEET MATERIAL FOR A SEMICONDUCTOR For: DEVICE AND A MANUFACTURING METHOD THEREOF, A MOLDING METHOD USING SUBSTRATE MATERIAL, A MANUFACTURING METHOD THEREOF OF

SEMICONDUCTOR DEVICES

Attorney Docket Number: 032121

Customer Number: 38834

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Date: July 8, 2005

Sir:

This paper is submitted in response to the Official Action dated June 14, 2005.

In the Action, restriction is required between Group I, Claims 1-6 and Group II, Claims 7-21.

Applicants hereby elect the subject matter of Group II, Claims 7-21 for prosecution in this application. This election is made without traverse, and it is understood that Applicants' rights to the filing of a divisional application directed to the non-elected subject matter under 35 U.S.C. §120 and 35 U.S.C. §121 are retained.

Response to Restriction Requirement Serial No. 10/718,677 Attorney Docket No. 032121

If this paper is not timely filed, Applicant(s) respectfully petition(s) for an appropriate extension of time. The fees for such an extension or any other fees that may be due with respect to this paper may be charged to Deposit Account No. 50-2866.

Respectfully submitted,

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